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|--|---|----|---|------------------------|--------------------------|--|
| | | | | Application Number | 10/553,893 | |
| INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary) | | | | Filing Date | 10/21/2005 Chistyakov | |
| | | | | First Named Inventor | | |
| | | | | Art Unit | Not Yet Assigned | |
| | | | | Examiner Name | Not Yet Assigned | |
| Sheet | 4 | of | 4 | Attorney Docket Number | ZON-005USN | |

| NON PATENT LITERATURE DOCUMENTS | | | | | | | |
|---------------------------------|--------------|---|----|--|--|--|--|
| Examiner Initials* | Cite No.1 | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T² | | | | |
| | C11 | SHERIDAN, ET AL., Electron Velocity Distribution Functions In A Sputtering Magnetron Discharge For The E x B Direction, J. Vac. Sci. Technol. A., Jul/Aug 1998, Pgs. 2173-2176, Vol. 16, No. 4, American Vacuum Society. | | | | | |
| | C12 | STEINBRUCHEL, A Simple Formula For Low-Energy Sputtering Yields, Appl. Phys. A., 1985, Pgs. 37-42, Vol. 36, Sprigner Verlag. | | | | | |
| | C13 | Encyclopedia Of Low Temperature Plasma, Pg. 119, Vol. 3 | ~ | | | | |
| | C14 | Encyclopedia Of Low Temperature Plasma, Pg. 123, Vol. 3 | ~ | | | | |
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